



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#32/G
10/23/31
Sunder

Application Serial No.09/233,377
Confirmation No.7580
Filing Date January 18, 1999
Inventor.....Gurtej S. Sandhu et al.
Assignee.....Micron Technology, Inc.
Group Art Unit.....2813
Examiner Pham, Thanhha S.
Attorney's Docket No.MI22-1114
Customer No.021567
Title: Method of Forming a Refractory Metal Silicide

RESPONSE TO JULY 9, 2003 OFFICE ACTION

To: Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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OCT 16 2003
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AMENDMENTS

In response to the Office Action of July 9, 2003, please amend the above-identified application as follows.